

F-7859

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Junichi ISHIZUKA
Filed : July 14, 2003
For : MOLDING METHOD OF MICROLENS ARRAY
AND MOLDING APPARATUS OF THE SAME

Mail Stop DD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

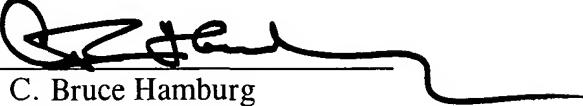
Sir:

Submitted herewith is an Information Disclosure Citation together with copies of references referred to therein.

Respectfully submitted,

Jordan and Hamburg LLP

By


C. Bruce Hamburg
Reg. No. 22,389
Attorney for Applicants

Jordan and Hamburg LLP
122 East 42nd Street
New York, New York 10168
(212) 986-2340

F-7859

Form PTO-1449 (Rev. 7-80) 42-44F (F-49)		U.S. Department of Commerce Patent and Trademark Office		Atty. Docket No.: F-7859		Serial No.: UNKNOWN		
				Applicant: Junichi ISHIZUKA				
				Filing Date: July 14, 2003		Group:		
U.S. PATENT DOCUMENTS								
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
		2001-48554	2/20/01	JP			Yes	No
		2000-1322	1/7/03	JP				N ^c
TRANSLATION KEY: * English Abstract. ^f Concise statement of relevance provided in foreign search report. ^c Concise statement of relevance provided in specification. ^s Concise statement of relevance provided in IDS. ^p Relevant portion of reference translated. ^o English abstract only - copy of reference in pct search.								
OTHER INFORMATION DISCLOSURE CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)								
EXAMINER					DATE CONSIDERED			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								